

RECEIVED
CENTRAL FAX CENTER

DEC 14 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE


Applicant:	Hechtl et al.	Art Unit:	1756
Serial No.:	10/631,082	Examiner:	Mohamedulla, S.
Filing Date:	07/31/2003	Docket No.:	TID-34165
Customer No.:	23494	Conf. No.:	2031
Title:	METHOD OF INSPECTING A MASK		

REQUEST FOR RECONSIDERATION UNDER 37 CFR 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at (571) 273 - 8300 on 12/14/2005.


Jacqueline J. Garner
Reg. No. 36,144

Dear Sir:

The following remarks are offered in response to the Examiner's Office Action dated 06/30/2005. They are respectfully submitted as a full and complete response to that Action.

REMARKS

Reconsideration of the above-referenced application in view of the following remarks is respectfully requested.

Claims 1-14 are pending in this case.

The Examiner rejected claims 1-14 under 35 U.S.C. 102(e) as being anticipated by Burdorf et al. (U.S. Patent 5,795,688).

Applicant respectfully submits that claim 1 is unanticipated by Burdorf as there is no disclosure or suggestion in the reference of patterning a semiconductor material with